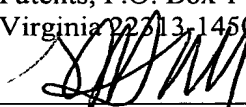




IFW

**PATENT**  
**30205/39407**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application of: Gyu Hyun Kim et al.	)	I hereby certify that this paper and the
	)	documents referred to as enclosed
Serial No.: 10/603,895	)	therewith are being deposited with the
	)	United States Postal Service as first
Filed: June 25, 2003	)	class mail, postage prepaid, on
	)	<b>August 20, 2004</b> , in an envelope
For: METHOD FOR	)	addressed to Commissioner for
MANUFACTURING	)	Patents, P.O. Box 1450, Alexandria,
SEMICONDUCTOR DEVICE	)	Virginia 22313-1450
	)	
Group Art Unit: 2813	)	Michael R. Hull
	)	Reg. No. 35,902
Examiner: Chandra P. Chaudhari	)	Attorney for Applicants

**COMMENT ON STATEMENT OF REASONS FOR ALLOWANCE AND  
AMENDMENT AFTER ALLOWANCE (37 CFR 1.312)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Commissioner:

In addition to the reasons for allowance set forth in the allowance papers that were mailed in connection with the present application, it is respectfully submitted that the claims are allowable for the additional reasons that the invention defined by the language of the claims is neither anticipated by, nor would have been obvious when taken as a whole in view of, the art of record.

A listing of claims and a Rule 312 Amendment begins on page 2 of this paper and remarks begin on 6 of this paper.